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DOCKET NO.: 4856/PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
IN THE MATTER OF THE PCT NATIONAL PHASE PATENT APPLICATION

OF: Matthias AIKELE et al.

USSN: TO BE ASSIGNED - NEW

FILED: March 14, 2005

USPS EXPRESS MAIL
EV 511 024 620 US
MARCH 14 2005

FOR: Method For Producing Insulation
Structures

INTERNATIONAL SERIAL NO.: PCT/DE2003/003049

INTERNATIONAL FILING DATE: 12 September 2003 (12.09.2003)

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P. O. BOX 1450
ALEXANDRIA, VA 22313-1450

March 14, 2005

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

- 1) Pursuant to 37 C.F.R. 1.56, 1.97 and 1.98 applicants enclose a Form PTO-1449 and make of record the documents listed thereon. A copy of the English version of the International Search Report issued in the counterpart PCT International Application on November 11, 2004 is enclosed. Copies of references AA, AB, AE and AF are not (and need not be) enclosed, because they were transmitted to the USPTO by the International Searching Authority in the International processing of this PCT Application.
- 2) This statement is being filed concurrently with the above identified new PCT National Phase Application.


The PTO did not receive the following
listed item(s) *

- 3) References AA to AF are in English. References AC and AD have been discussed at pages 1 and 2 of the specification. Therefore, no further discussion of the references is required.
- 4) Moreover, the enclosed Search Report indicates the degree of relevance of each of the references AA, AB, AE and AF by category (A = technological background). Thereby, a concise explanation of the relevance has been provided (see M.P.E.P. §609).
- 5) The Examiner is requested to consider all references of record, return an initialed copy of the enclosed Form PTO-1449 and ensure that all references of record are printed on any patent issuing from this application.

Respectfully submitted,

Matthias AIKELE et al.
Applicant

WFF:hc/4856/PCT
Encls.: postcard,
First Form PTO-1449,
copy of English Version of
International Search Report

By 
Walter F. Fasse
Patent Attorney
Reg. No.: 36132
Tel. No.: (207) 862-4671
Fax. No.: (207) 862-4681
P. O. Box 725
Hampden, ME 04444-0726

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Sheet 1 of 1
**FIRST IDS LIST OF REFERENCES
 CITED BY APPLICANT**
 (FORM PTO-1449)
DATED: March 14, 2005

Atty. Docket No. **4856/PCT**
 Serial No.: **To Be Assigned**

Applicant: **Matthias AIKELE et al.**

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March 14, 2005

Art Unit:

U. S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	Cl.	Sub- Cl.	Fil. Date
/KC/	AA	5,041,898	08/1991	Urabe et al.	-	-	-
/KC/	AB	5,747,377	05/1998	Wu	-	-	-
/KC/	AC	5,930,595	07/1999	Sridhar et al.	-	-	-
/KC/	AD	6,239,473	05/2001	Adams et al.	-	-	-
/KC/	AE	6,342,427	01/2002	Choi et al.	-	-	-

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	Cl.	Sub- Cl.	Trans.	
							Yes	No

OTHER DOCUMENTS

/KC/	AF	Chunbo Zhang et al.; "Fabrication of thick silicon dioxide layers using DRIE, oxidation and trench refill"; IEEE, 2002, pages 160-163, XP010577620						

EXAMINER'S SIGNATURE

/Kin Chan Chen/

DATE CONSIDERED

06/11/2009

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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